

Jc 4 (920)



	Subclass
	Class

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PATENT NUMBER

U.S. UTILITY PATENT APPLICATION

PATENT DATE

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/816784	F	428 216	41	1775 1746	VINH

APPlicants

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1765

iii

Dry etching method, microfabrication process and dry etching mask

PTO-2040
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PREPARED AND APPROVED FOR ISSUE

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(LABEL AREA)

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